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Front Matter: Volume 10839

, "Front Matter: Volume 10839," Proc. SPIE 10839, 9th International Symposium on Advanced Optical Manufacturing and Testing Technologies: Optical Test, Measurement Technology, and Equipment, 1083901 (18 January 2019); doi: 10.1117/12.2523486



Event: Ninth International Symposium on Advanced Optical Manufacturing and Testing Technologies (AOMATT2018), 2018, Chengdu, China

# PROCEEDINGS OF SPIE

9th International Symposium on Advanced Optical Manufacturing and Testing Technologies

# Optical Test, Measurement Technology, and Equipment

Fan Wu Yudong Zhang Xiaoliang Ma Xiong Li Bin Fan Editors

26–29 June 2018 Chengdu, China

Organized by Institute of Optics and Electronics, Chinese Academy of Sciences (China)

Sponsored by
COS—The Chinese Optical Society (China)
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Published by SPIF

**Volume 10839** 

Proceedings of SPIE 0277-786X, V. 10839

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AOMATT 2018: Optical Test, Measurement Technology, and Equipment, edited by Fan Wu, Yudong Zhang, Xiaoliang Ma, Xiong Li, Bin Fan, Proc. of SPIE Vol. 10839, 1083901 © 2019 SPIE · CCC code: 0277-786X/19/\$18 · doi: 10.1117/12.2523486

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Author(s), "Title of Paper," in AOMATT 2018: Optical Test, Measurement Technology, and Equipment, edited by Fan Wu, Yudong Zhang, Xiaoliang Ma, Xiong Li, Bin Fan, Proceedings of SPIE Vol. 10839 (SPIE, Bellingham, WA, 2019) Seven-digit Article CID Number.

ISSN: 0277-786X

ISSN: 1996-756X (electronic)

ISBN: 9781510623200

ISBN: 9781510623217 (electronic)

Published by

SPIE

P.O. Box 10, Bellingham, Washington 98227-0010 USA Telephone +1 360 676 3290 (Pacific Time) · Fax +1 360 647 1445

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Printed in the United States of America.

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